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Docket No.: M4065.0073/P073  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Donald L. Yates

Application No.: 09/123,430

Group Art Unit: 2823

Filed: July 28, 1998

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE  
CONTAMINATION IN  
SEMICONDUCTOR WET-PROCESSING  
VESSELS

RECEIVED  
DEC 18 2002  
TECHNOLOGY CENTER 2800

REQUEST FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

Applicant hereby petitions for a one month extension of time to and including December 14, 2002 to respond to the Office Action mailed August 14, 2002.

In the event that a further petition for an extension of time is required to be submitted at this time, applicant hereby petitions under 37 CFR 1.136(a) for an extension of time for as many months as are required to ensure that the above-identified application does not become abandoned.

Please charge our Credit Card in the amount of \$110.00 covering the fee set forth in 37 CFR 1.17(a)(1). Credit Card Payment Form SB-2038, with a signature from an authorized cardholder, is enclosed. The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith

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(or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 04-1073, under Order No. M4065.0073/P073.

Dated: December 13, 2002

Respectfully submitted,

By 

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